



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Akito Hara
Serial No.: 10/790,875
Conf. No.: 4718
Filed: 3/2/2004
For: SEMICONDUCTOR DEVICE
AND METHOD OF
FABRICATING THE SAME
Art Unit: 2811
Examiner: Nguyen, Cuong Quang

I hereby certify that this paper is being deposited with the United States Postal Service as FIRST-CLASS mail in an envelope addressed to: MS Issue Fee, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on this date.

6 April 2005 
Date Registration No. 29,367
Attorney for Applicant(s)

REQUEST FOR ACKNOWLEDGEMENT OF PREVIOUSLY CITED REFERENCE

Mail Stop Issue Fee
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Applicants request acknowledgement of the Makihiro reference cited in an Information Disclosure Statement on June 7, 2004. The Makihiro reference was not acknowledged, apparently through inadvertent error. A copy of the initialed PTO-1449 form and the Makihiro reference is enclosed.

Respectfully submitted,

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By 

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Form PTO-1449
(Rev. 8-88)U.S. Department of Commerce
Patent & Trademark Office

Attorney Docket No.: 1117.69877

Serial No.: 10/790,875

Applicant: Akito Hara

INFORMATION DISCLOSURE CITATION
(Use several sheets if necessary)

Filing Date: 3/2/2004

Group: 2811

U.S. PATENT DOCUMENTS

Examiner Initial*	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
Ch	2002/0031876	Mar. 14, 2002	Hara et al.	438	166	8-22-01

FOREIGN PATENT DOCUMENTS

	Document Number	Date	Country	Class	Subclass	Translation	
						Yes	No
Ch	10-173192	Jun. 26, 1998	Japan			Abs. only	
Ch	2002-033481	Jan. 31, 2002	Japan			Abs. only	

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

	Makihira et al.; Double-Gate Poly-Si Thin-Film Transistors Fabricated Using Self-Aligned Technology; Am-LCD '01; Digest of Technical Papers; July 11-13, 2001

Examiner

Date Considered

*Examiner:

Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.